BIRLA INSTITUTE OF TECHNOLOGY AND SCIENCE – PILANI, K K BIRLA GOA CAMPUS FIRST SEMESTER 2019-2020

PHY F426 & PHY G541	Comprehensive Exam (Closed book)	Time: 3 hrs
Physics of Semiconductor Devic	es Date: 13/12/2019	Time: 9 AM – 12 noon
		Max. Marks: 80

Part A (5 marks each)

- 1) What is the difference between density of states and effective density of states? Why is the latter such a useful concept?
- 2) An unknown semiconductor has $E_g = 1.1$ eV and $N_c = N_v$. It is doped with 10^{15} cm⁻³ donors, where the donor level is 0.2 eV below E_c . Given that E_f is 0.25 eV below E_c , calculate n_i and the concentration of electrons and holes in the semiconductor at 300 K.
- 3) What are the two material parameters that determine the carrier transport in semiconductors? Discuss the carrier transport in semiconductors quantitatively with necessary equations.
- 4) Briefly describe pn junction capacitance.
- 5) Draw a laser p-n junction at equilibrium and at forward bias. Mark the bands. Explain briefly how it works.
- 6) Consider a silicon pn junction diode at 300 K with an applied forward bias voltage V=0.65 V. $N_a = N_d = 10^{16}$ cm⁻³. Given that the total current far from the junction in the n-region will be majority carrier electron drift current, calculate the electric field required to produce this drift current.

Part B

- 7) We deposit a metal with a work function of 4.6 eV on silicon (electron affinity of 4 eV) and acceptor doping level of 10¹⁸ cm⁻³. Draw the equilibrium band diagram and mark off the Fermi level, the band edges and the vacuum level. Is this a Shottky or ohmic contact? Why? By how much should the metal work function be altered to change the type of contact? Explain with reference to the band diagram.
- 8) (a) Derive an expression for the density of states of a one dimensional crystal. Take *L* as the length of the crystal, *b* as the width and *c* as the thickness.
 - (b) Find out the permitted energy levels for the electrons in the crystal given that it is confined in both *y* and *z* directions.
 - (c) Draw the density of states as a function of energy and explain. [3+6+5]
- 9) Consider the following MOSFET characteristics. Answer the questions below. <u>Justify every</u> <u>answer.</u>



- (a) Is this an n-channel or p- channel device?
- (b) Does this appear to be long channel or short channel device?
- (c) What is the apparent threshold voltage V_T ?
- (d) Is this a depletion-mode or enhancement-mode MOSFET?
- 10) (a) What are quantum dots? What is the role of quantum dot in single electron transistors?(b) What is Coulomb blockade? What are the criteria to achieve Coulomb blockade?

[2x4]

[4x2]

- 11) (a) What are Chiral vectors? How is it important in determining the electrical properties of carbon nanotubes?
 - (b) Describe Raman scattering? Why is it known as 'molecular finger print' of materials?
 - (c) What is spin Hall effect? How is it different from normal Hall effect? [3x4]

Useful parameters and equations: The symbols have the usual meaning

 $n_i = 1.5 \times 10^{10} \text{ cm}^{-3}$, $D_n = 25 \text{ cm}^2/\text{s}$, $D_p = 10 \text{ cm}^2/\text{s}$, $\tau_{p0} = \tau_{n0} = 5 \times 10^{-7} \text{ s}$, $\mu_n = 1350 \text{ cm}^2/\text{V-s}$ for either $n_0 = 10 \text{ cm}^2/\text{s}$, $\tau_{p0} = 10 \text{ cm}^2/\text{s}$, $\tau_{p0} = 10 \text{ cm}^2/\text{s}$, $\mu_n = 1350 \text{ cm}^2/\text{V-s}$ for $\mu_n = 10 \text{ cm}^2/\text{s}$.

silicon

Intrinsic electron concentration,

$$n = 2\left(\frac{2\pi m_{\theta}^* k_B T}{h^2}\right)^{3/2} exp\left(\frac{E_F - E_C}{k_B T}\right)$$

Intrinsic hole concentration,

$$p = 2\left(\frac{2\pi m_h^* k_B T}{h^2}\right)^{3/2} exp\left(\frac{E_V - E_F}{k_B T}\right)$$

The ideal reverse saturation current density is given by

$$\frac{eD_nn_{p0}}{L_n} + \frac{eD_pp_{n0}}{L_p}$$